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D-3213

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT

In re application of:

Calvez et al.

Serial No. 10/550,846

Filed: March 24, 2004 (I.A.)

For: IMPROVEMENTS IN AND
RELATING TO VERTICALCAVITY SEMICONDUCTOR
OPTICAL DEVICES

Group Art Unit: Unknown

Examiner: N/A

Examiner: N/A

OCAUTY SEMICONDUCTOR
OPTICAL DEVICES

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INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant wishes to call to the attention of the Examiner the documents cited on the accompanying Form PTO-1449. No concession is made that these documents are prior art, and applicant expressly reserves the right to antedate the documents as may be appropriate. Applicant requests that each of these documents be made of record in the above-identified application.

Respectfully submitted,

Attorney for Applicant

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)			Docket No.: D-3213 Application No.: 10/550,846					
			Applicant: Calvez et al.					
			Filing Date: March 24, 2004		Group Art Unit: Unknown			
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